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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of : Mail Stop Amendment
Dong-Jin Park et al. : Group Art Unit: 1751
Serial No. 10/739,203 : Examiner: Webb, Gregory E
Filed December 19, 2003 :

Title: RESIST AND ETCHING BY-PRODUCT REMOVING COMPOSITION AND RESIST REMOVING
METHOD USING THE SAME

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir:


This is in response to the Office action dated April 27, 2006.

Applicants wish to thank the Examiner for the courtesy of a telephone interview with the undersigned on May 11, 2006. In the telephone interview, the Examiner acknowledged that the restriction requirement was issued in error and would be withdrawn.

As a result of the Preliminary Amendment dated December 19, 2003, method claims 23-41 are now pending in the application.

Respectfully submitted,

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